

A Table-Top Experimental setup Testing Silicon Sensors

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Motivation

- **Advantages of Test Beams:**
- High-energy particles with low multiple scattering provide the necessary precision for detailed spatial mapping.
- **Challenges with Test Beams:**
- Require time slots and resources at dedicated facilities (e.g., CERN SPS, DESY).
- Complex setup with specialized tracking telescopes like the EUDET telescope with MIMOSA planes.
- **Our Purpose**
- A discussion on beta particle calibrating the silicon sensors

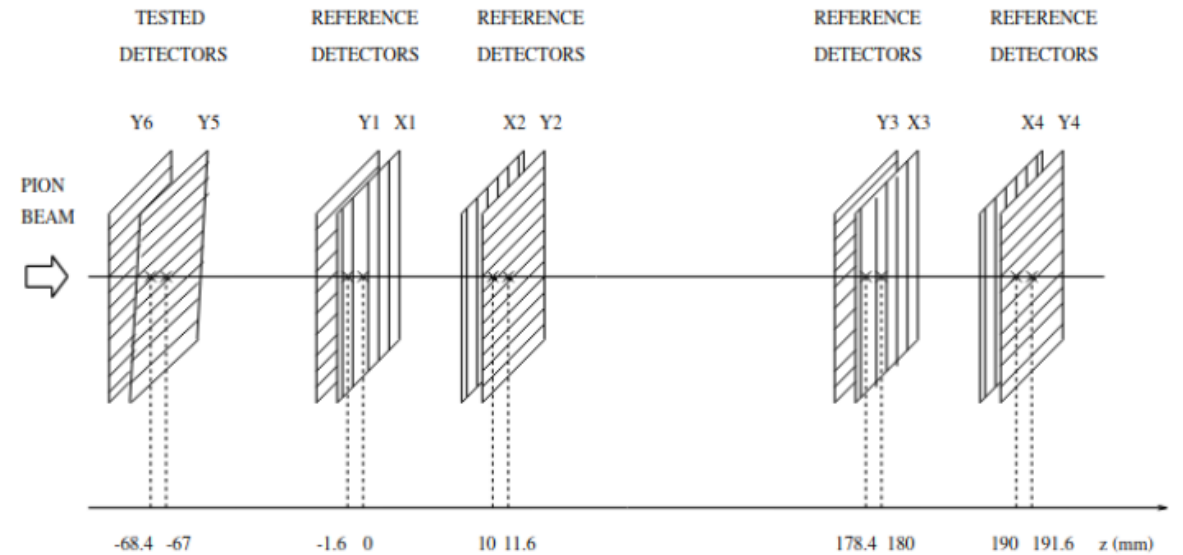
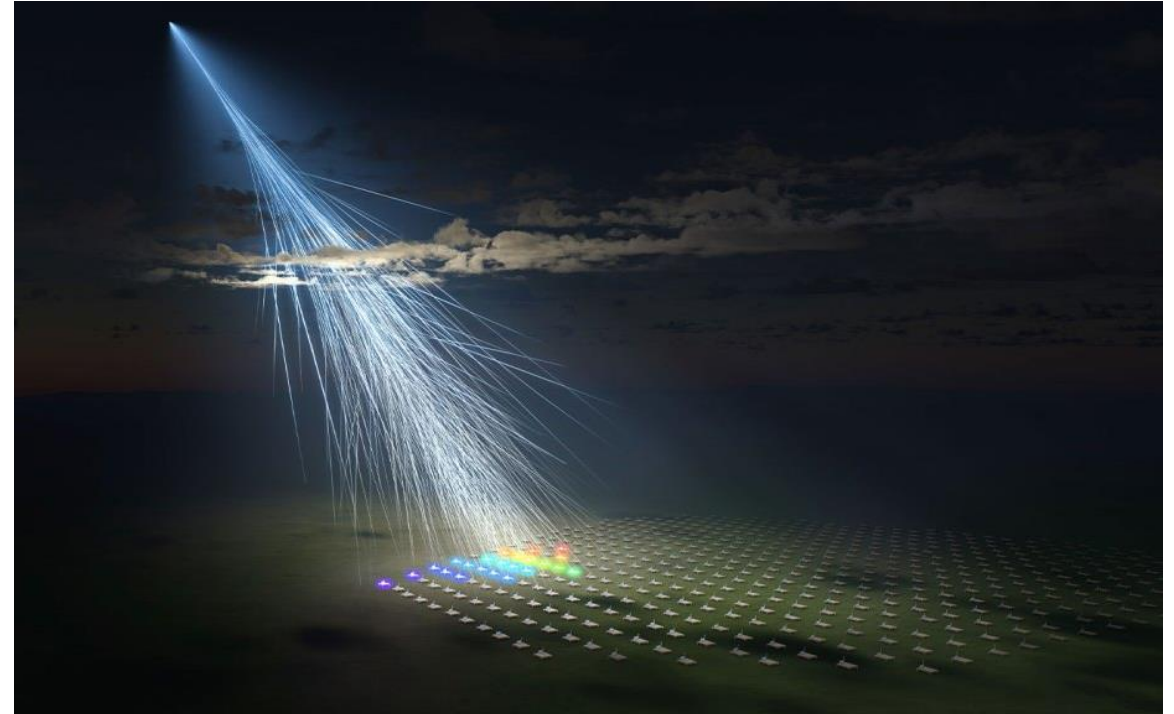


Figure 3: Detector telescope used with a pion beam. The relative positions of the different detectors are reported (in *mm*) with respect to the X_1 detector, used as the origin.

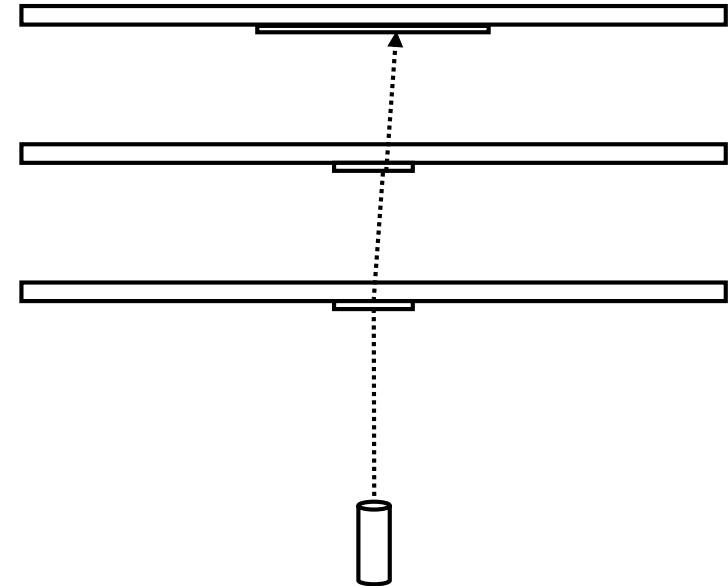
Cosmic Ray Muons?

- **Advantage:**
 - Low multiple scattering
- **Rate of Cosmic Rays:**
 - Muons arrive at ~ 1 muon/min/cm².
- **Time Requirement:**
 - For a 1mm x 1mm DUT with 5 μ m x 5 μ m bins and ~ 100 events per bin
 - Need **~ 100 years** by assuming 100% muon detections efficiency for calibration



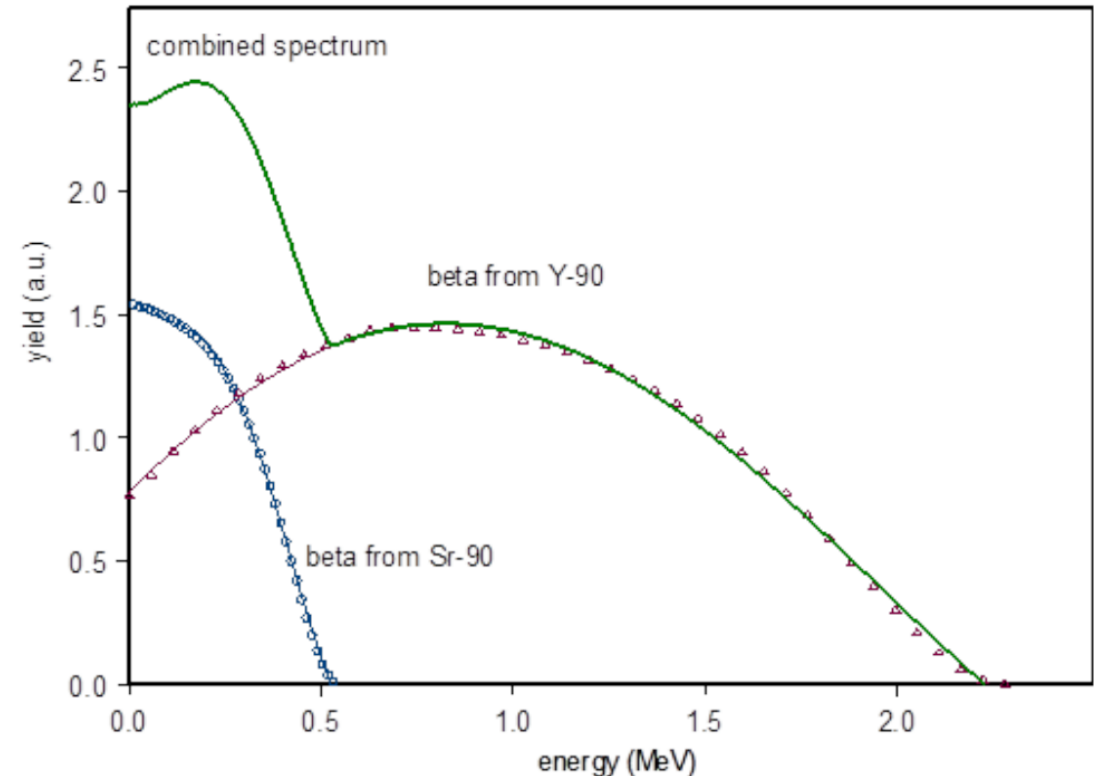
A Table-Top Experiment

- **High-Energy Beta Particles:** Ensures effective penetration and minimal scattering.
- **Detector Configuration:** DUT sandwiched between detectors, with a pixel detector as the final layer.
- **Calibration Goals:** Achieve both time and spatial calibration.
- **Key Considerations:**
 - Source Selection
 - Geometry Placement
 - Multiple-Scattering Analysis

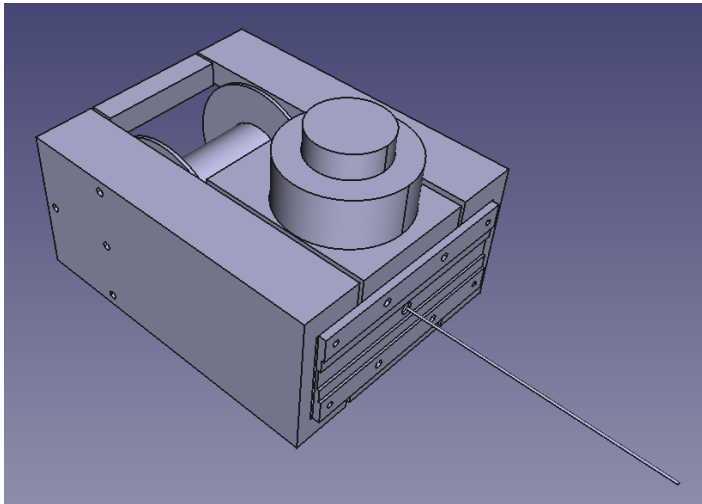


Source Consideration

- **Source Requirements**
- **High-Energy Particles:** Ensures effective penetration and minimal scattering.
- **Stability During Testing:** Long enough half-life to maintain consistent emission over the testing period.
- **Phosphorus-32P**
 - **Maximum Energy:** 1.71 MeV
 - **Half-Life:** ~14.3 days
- **106Ru and 106Rh**
 - **Maximum Energy:** 3.54 MeV (from ^{106}Rh decay)
 - **Half-Life:** ^{106}Ru ~373.6 days; ^{106}Rh , ~30 seconds.
- **Chosen Source:** ^{90}Sr with a beta spectrum up to 2.28 MeV



Particle Selection - Electron Monochromator



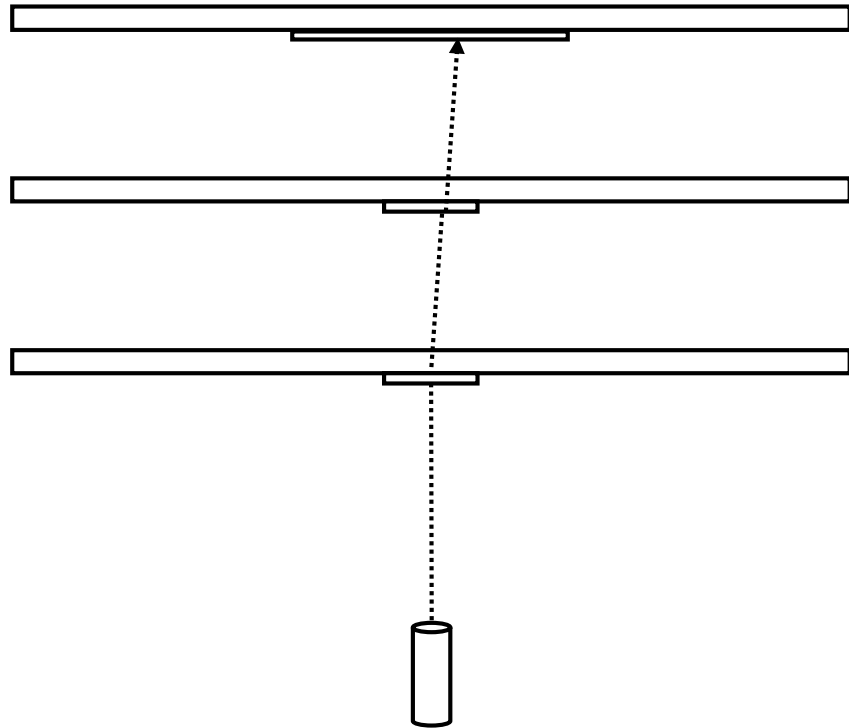
Momentum Selection performance

- **High-Energy Selection:** Reduce multiple-scattering, increase the selection precision.
- **Momentum Precision:** Generally better than 10%, reaching approximately 5% for momenta above 1.5 MeV/c. (*Source: S. Arfaoui, C. Joram, C. Casella, 2015*)

High-Activity Source Requirement

- **Trigger Rate:** Typical trigger rate of around 10 Hz, achieved with thick, square scintillating fibers positioned approximately 1 cm from the exit slit. (*Source: S. Arfaoui, C. Joram, C. Casella, 2015*)

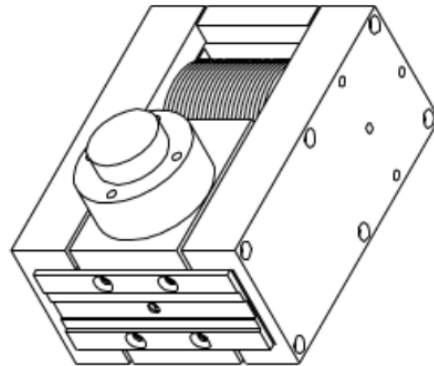
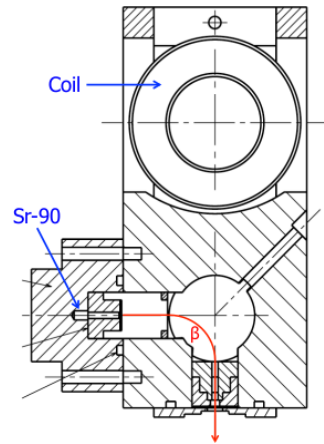
Geometry Placement



Geometry placement

- details:

Scanning Tracking Technique



General Idea:

- Create a **detailed spatial map** of the sensor's response

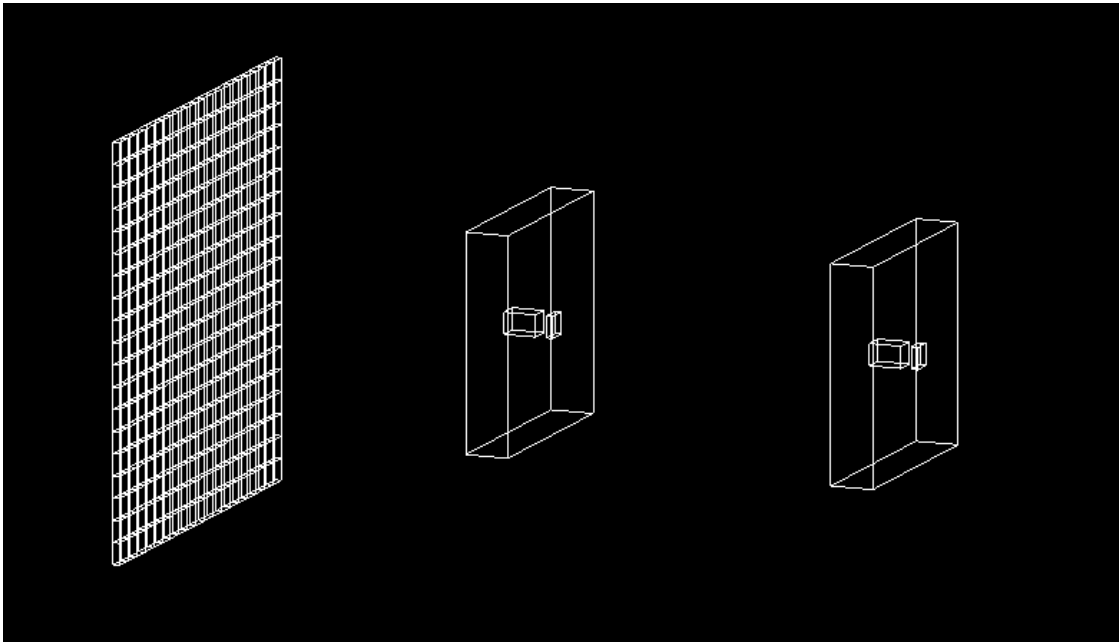
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Initial Investigation

- Evaluate the feasibility of the proposed setup using a simplified particle source model.
- By utilizing Geant4 simulations to optimize the geometry for a configuration that minimizes scattering effects, ensuring accurate trajectory measurements.
- **Key Parameter - $\Delta\theta$** : Define $\Delta\theta$ as the angular deviation of a particle moving through each detection sensor.

Geant4 Simulation - Geometry



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High-Activity Source Requirement

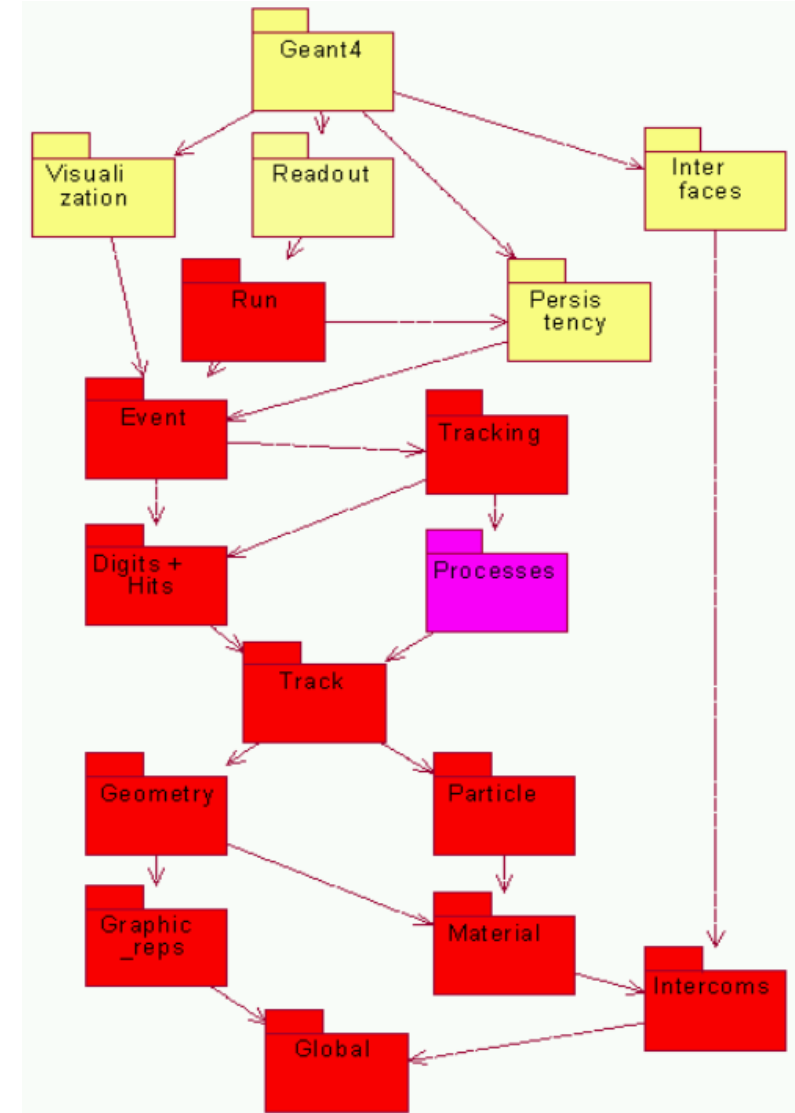
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Geant4 Simulation - Physics List

- RegisterPhysics(new **G4DecayPhysics()**);
- RegisterPhysics(new **G4RadioactiveDecayPhysics()**);
 - To generate decay process
- RegisterPhysics(new **G4EmStandardPhysics_option4()**);
 - Compared to **G4EmStandardPhysics**, option4 provides higher accuracy in Multiple Scattering simulation below $\sim 100\text{MeV}$ (V. Ivanchenko, 2018)

Geant4 Simulation – Simulation Structure

- Some thing like this?



Geant4 Simulation – Material definition

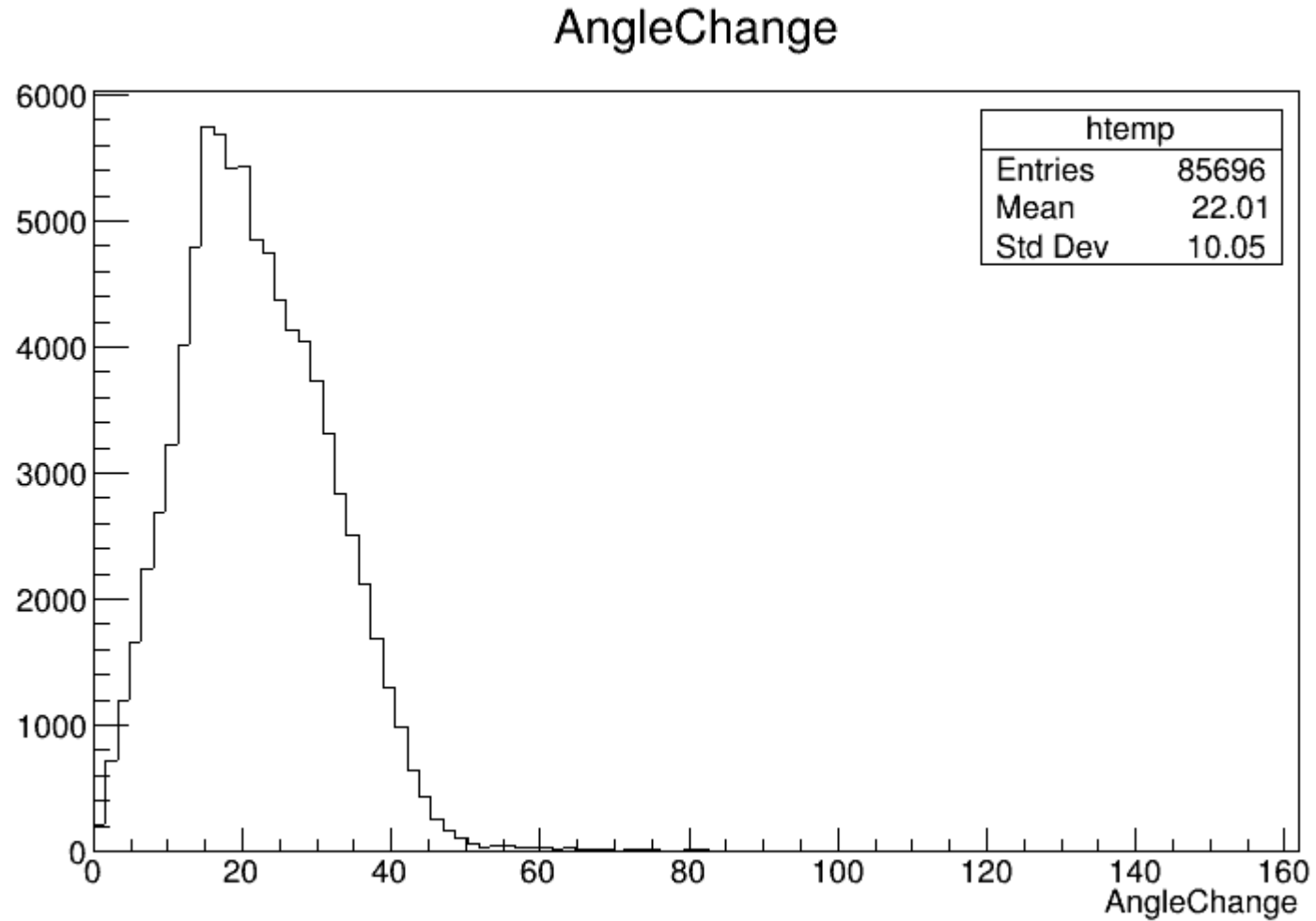
- Silicon Sensors:
 - Assuming pure silicon crystal – G4_Si
- Detector Holder Plate:
 - Woven Glass Fabric composition (15%):
 - Silicon (Si): ~33-35%; Oxygen (O): ~48-50%; Aluminum (Al): ~10-15%; Calcium (Ca): ~3-5%; Magnesium (Mg): ~1-2%
 - Ceramic filler (55%):
 - Oxygen (O): ~50-60%; Silicon (Si): ~20-30%; Aluminum (Al): ~5-15%; Calcium (Ca): ~1-5%; Magnesium (Mg): ~1-3%
 - Hydrocarbon Resin (30%):
 - Carbon (C): ~85-90%; Hydrogen (H): ~8-10%; Oxygen (O): Trace to 5%

Geant4 Simulation – Particle Gun and Tracking Actions

- Option 1 - decay generator:
 - Create random number 0-1, randomly pick 90Sr and 90Y decay process, to get a mixture spectrum
 - Kill the electron tracks if the direction is out side the emitting angle, and kill all the non-electron tracks
 - 1 decay in each G4Event
- Option 2 – Electron particle gun:
 - 2.2MeV electron particle gun, momentum alines on z direction
 - 1 electron generated in each G4Event
- Stop generating until 10^6 tracks are recorded

Primary Results – Total Angular deviation

- by ge



Primary Results – Distribution

- by ge

